



IFW

Attorney Docket # 5405-9

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yuusuke KAWAHARA et al.

Serial No.: 10/668,777

Filed: September 22, 2003

For: Manufacturing Method of Circuit Substrate,
Circuit Substrate and Manufacturing Device of
Circuit Substrate

Examiner: TRINH, Michael M.
Group Art: 2822

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

March 10, 2005
(Date of Deposit)

Thomas Langer
Name of applicant, assignee or Registered Representative

Thomas Langer

Signature

March 10, 2005
Date of Signature

Mail Stop **Amendment**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

SIR:

This is in response to the Restriction Requirement dated February 10, 2005 setting a shortened statutory period for response expiring March 12, 2005.

Applicants hereby elect claims 1-10 of Group II for further prosecution in the present application. This election is being made without traverse.

Prompt examination of this application on the merits is now respectfully requested.

Respectfully submitted,
COHEN, PONTANI, LIEBERMAN & PAVANE

By

Thomas Langer

Thomas Langer, Reg. No. 27,264
551 Fifth Avenue, Suite 1210
New York, New York 10176
(212) 687-2770

Dated: March 10, 2005